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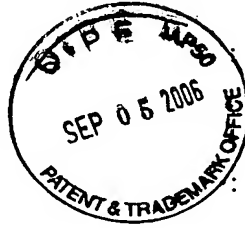
IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

SHIHO OKUNO, ET AL.

SERIAL NO: 10/796,086

FILED: MARCH 10, 2004



EXAMINER: TUGBANG, A.D.

: GROUP ART UNIT: 3729

FOR: MAGNETORESISTANCE EFFECT :  
ELEMENT, ITS MANUFACTURING  
METHOD, MAGNETIC REPRODUCING  
ELEMENT AND MAGNETIC MEMORY

ELECTION WITHOUT TRAVERSE

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

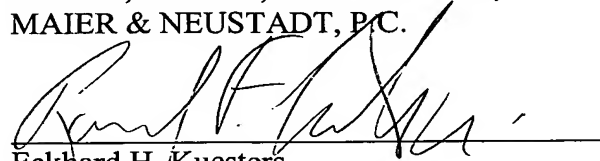
In response to the communication dated August 2, 2006, and further in response to the Restriction Requirement contained therein, Applicants herein elect, without traverse, the invention of Group I, Claims 20 and 21, indicated in the Requirement to be drawn "to a process of making a magnetoresistance effect element including depositing a second ferromagnetic material, classified in class 29, subclass 603.14."

Application No. 10/796,086  
Reply to Office Action of 08/02/06

In view of the present election without traverse of the invention of Group I, Claims 20 and 21, it is respectfully submitted that an action on the merits as to elected Claims 20 and 21 should be forthcoming.

Respectfully submitted,

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